



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

PATENT

APPLICANT: K. Aratani, et al.

SERIAL NO.: 09/429,719

FILED: October 29, 1999

FOR: THIN FILM FORMATION USE
SPUTTERING TARGET MATERIAL,
THIN FILM FORMED USING SAME,
AND OPTICAL RECORDING MEDIUM

CASE NO.: 9792486-0100

EXAMINER: R. McDonald

DATE: September 12, 2001

GROUP ART UNIT: 1753

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the:

Assistant Commissioner for Patents
Washington, D.C. 20231

Date of Deposit: September 12, 2001

JoEllen Hogan 9/12/01
JoEllen Hogan Date

11/W.M.
9/20/01

REQUEST FOR EXTENSION OF TIME

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicant hereby petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated May 11, 2001, for one (1) month from August 11, 2001 to September 11, 2001. Enclosed is a check in the amount of \$110.00 to cover the cost of the extension.

The Commissioner is hereby authorized to charge any additional fees required, as well as any patent application processing fees associated with this communication for which full payment has not been tendered, to Deposit Account No. 19-3140. A duplicate copy of this sheet is attached.

09/19/2001 CNGUYEN 00000066 09429719

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110.00 OP

Respectfully submitted,

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